# Optics for laser measurements 

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## Outline

Geometrical optics
lenses
ray tracing
aberrations
Physical optics
diffraction and Fourier optics
Gaussian optics
reflections and coatings
More stuff
reflections
coatings
interference
polarization optics

## Power of refracting surfaces

Fermat's principle of least time: $n_{1} L_{1}+n_{2} L_{2}$ is stationary $(d(\Sigma n L) / d L=0)$


Approximating as a spherical surface, refractive power $=1 / \mathrm{f}$

$$
\text { power }=\frac{1}{f}=\left(\frac{n_{2}}{n_{1}}-1\right)\left(\frac{1}{R}\right)
$$

and gives curved surfaces focusing power


R

## Thick lens (and lensmaker's equation)

A lens is transmitting optic that has refractive power


$$
\text { power }=\frac{1}{f}=(n-1)\left(\frac{1}{R_{1}}+\frac{1}{R_{2}}+\frac{(n-1) d}{n R_{1} R_{2}}\right)
$$

## Types of lenses



Coddington shape factor

$$
q=\frac{R_{2}+R_{1}}{R_{2}-R_{1}}
$$



## A lens with negative power

$$
\text { power }=\frac{1}{f}=-(n-1)\left(\frac{1}{\left|R_{1}\right|}+\frac{1}{\left|R_{2}\right|}-\frac{(n-1) d}{n R_{1} R_{2}}\right)
$$

## Curved mirrors have power

For a mirror, $\mathrm{n}=-1$

$$
\text { power }=\frac{1}{f}=(n-1)\left(\frac{1}{R}\right) \quad \text { so } \mathrm{f}=-\mathrm{R} / 2
$$



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## The thin lens - a useful simplification

A thin lens has radii of curvatures greater than thickness $\left(R_{1}, R_{2}>d\right)$

For a thin lens in air

$$
\text { power }=\frac{1}{f}=(n-1)\left(\frac{1}{R_{1}}+\frac{1}{R_{2}}\right)
$$


$f$ is measured from the principal plane $P$
A thick lens may have two non-coincident principal planes

## Simple ray tracing

An object $h$ units high creates an image $h$ ' units high


Can map the object to the image using two of three rays:

- Ray parallel to axis to principal plane, then though back focal point
- Ray through front focal point to principal plane, then parallel to axis
- Ray through nodal point

Points x and x ' are called conjugates
see http://www.colorado.edu/physics/phet/simulations/lens/lens.swf

## Simple two-lens system

If lenses are separated by more than sum of focal lengths

- find an intermediate image
- map the intermediate image to the final image


Question...How does the lens diameter affect the image???

## Imaging equations



## Beam expanders

Can expand beam by separating two lenses by the sum of their focal lengths

$$
\frac{D_{2}}{D_{1}}=\frac{f_{2}}{f_{1}}
$$

Galilean telescope


Does the lens diameter matter?
Which telescope is better for high pulse-energy lasers?

## Beam shaping

Non-circular beams (e.g., laser diodes) can be "circularized" in onedimension using cylindrical lenses or prisms


This method provides 1-d compression/expansion
To avoid the beam offset, use cylindrical lenses in a telescope

## Aberrations

The perfect (or "stigmatic") imaging discussed before occurs for hyperboliods


Ray optics assumes spherical surfaces...

- this only works in the "paraxial" (small angle, where $\sin x=x$ ) limit
- we ignored $x^{3} / 3!+x^{5} / 5!-\ldots$ in the expansion of $\sin x$

Aberrations exist when the marginal rays don't focus at the same place as the paraxial rays

The third-order aberrations are:

- spherical
- coma
- astigmatism
- field curvature
- distortion
increasing
dependence on
distance from
image plane axis


## Focused spots with aberration



Ray trace for coma



Ray trace for astigmatism

Two perpendicular foci

Astigmatism is common in laser diodes

## Spherical aberration

Spherical aberration causes on-axis distortion


- SA causes a radially symmetric spread of the focused point
- Smallest "spot" will occur in front of paraxial focus plane


## SA depends on lens shape



Aberration is minimized when the incident angles to the optical surface are minimized


Rule of thumb: point most curved surface towards most distant conjugate

## Pictures of SA though focus

Focal Planes with Spherical Aberration


Java tutorial at http://www.olympusmicro.com/primer/anatomy/aberrationhome.html

## Numerical aperture \& F-number

Numerical aperture


$$
\begin{aligned}
& \mathrm{NA}=\mathrm{n} \sin \theta_{\max } \\
& n=1 \text { for lens in air }
\end{aligned}
$$

$F \#=f / D$

One can "stop down" to reduce the NA or increase the F\#

$N A=n \sin \theta$
F\# = f/D*

## Aberration scaling

The severity of aberrations generally depends on the aperture stop diameter ( D ) and the off-axis distance of the image point (h')

Dependence on

| Aberration | $D$ |
| :--- | :--- |
| Spherical aberration | $D^{3}$ |
| Coma | $D^{2}$ |
| Astigmatism | $D$ |

$\frac{h^{\prime}}{\text { none }}$
$h^{\prime}$
$h^{\prime 2}$

High NA or low F\# systems have more SA than low NA / high F\# systems

## Physical optics

In geometric optics, a bundle of rays parallel to the axis will focus to a point In real life, the spot size is finite even if aberrations are zero

## Diffraction



Diffraction: the interference phenomena that describes the alteration of wave propagation due to optics of finite size

Ray model (no diffraction) Wave model (with diffraction)

irradiance


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## Wave optics

diffraction creates intensity distributions geometric optics cannot explain


Arago's (or Poisson's) spot
To model the general propagation of a wave through space...

$$
\begin{aligned}
& U(x, y, z)=E(x, y, z) \exp [-j(\omega t+\phi(x, y, z)] \\
& U\left(x_{0}, y_{0}, z\right)=\frac{z}{j \lambda} \iint_{\text {surface }} U\left(x_{1}, y_{1}\right) \frac{\exp \left(j k r_{01}\right)}{r_{01}{ }^{2}} d x_{1} d y_{1} \\
& \text { for } r_{01} \gg \lambda
\end{aligned}
$$



## Fourier optics

The diffraction pattern is very complicated and evolves with the distance $z$ from the aperture...need simplifications!!

In the far field (or "Fraunhofer region") the field math is simplified:
Here the field is the Fourier transform of the wavefront in the aperture

The far field exists at distances

$$
z>\frac{2 D^{2}}{\lambda}
$$

or
at the focal plane of a lens


## Fourier transform pairs



## Airy function

The intensity distribution of a plane wave incident on a circular aperture with radius w is:

$$
I(R) \propto\left[\frac{J_{1}(k w R / z)}{k w R / z}\right]^{2}
$$

Diffraction-limited spot


## Diameter of central lobe

$$
\begin{aligned}
& d=1.22 \frac{\lambda z}{w} \quad \text { for } z>\frac{2 D^{2}}{\lambda} \\
& \text { or } \\
& d=1.22 \frac{\lambda f}{w} \quad \text { at the focal plane }
\end{aligned}
$$

$\sim 86 \%$ of energy is in the central lobe

## Beam divergence

Beyond the far field, the beam diverges at a constant angle

$\Theta \cong 0.61 \frac{\lambda}{w} \quad$ in the far field

## Gaussian beams

- Spherical-mirror resonator modes are Hermite-Gaussian
- Lowest-order mode is a Gaussian beam
- Hermite-Gaussians functions are self-transforms


$$
I(r)=\frac{2 P}{\pi w^{2}} \exp \left[\frac{-2 r^{2}}{w^{2}}\right]
$$

$w$ is the $1 / \mathrm{e}^{2}$ radius
(or the $1 / \mathrm{e}$ radius for the E field)

## Gaussian beam propagation

Gaussian beam propagation is defined by the wavelength and $\mathrm{w}_{0}$, the radius of the beam at the waist


Beam radius at $z$

$$
w(z)=w_{0} \sqrt{1+\left(\frac{Z}{Z_{R}}\right)^{2}}
$$

Radius of curvature at $z$

$$
R(z)=z+\frac{z_{R}^{2}}{z}
$$

$$
Z_{R}=\frac{\pi w_{0}^{2}}{\lambda}
$$

## Rayleigh range

The Rayleigh range is distance from waist at which beam area doubles
Rayleigh range

$$
Z_{R}=\frac{\pi w_{0}^{2}}{\lambda}
$$

$Z_{R}=\frac{\pi w_{0}{ }^{2}}{\lambda}$
$2 Z_{R}$ is know as the "confocal region" or "depth of focus"

## "collimated" beam range



Tighter focusing causes a smaller "collimated" range


## Gaussian beam divergence



$$
w(z)=w_{0} \sqrt{1+\left(\frac{z \lambda}{\pi w_{0}^{2}}\right)^{2}} \cong \frac{z \lambda}{\pi w_{0}} \quad \text { for large } z\left(z \gg z_{R}\right)
$$

Beam divergence

$$
\theta_{1 / e}=\lim _{z \rightarrow \infty} \frac{w(z)}{z}=\frac{\lambda}{\pi w_{0}}
$$

Divergence is inversely proportional to w

## Focusing a Gaussian beam

Recall $w(z) \cong \frac{z \lambda}{\pi w_{0}}$
At focus, spot radius is $w_{0} \cong \frac{\lambda f}{\pi w}$


There is a (usually negligible) shift $\Delta f$ between the waist position and geometric focus

## Truncated Gaussian beams



Choose lens diameter > Tw to transmit > 99\% of energy

Transmittance T through aperture is

$$
T=1-\exp \left[-\frac{2 a^{2}}{w^{2}}\right]
$$



## Truncated Gaussian problems

Truncating the Gaussian beam causes

- Decrease in total power transmitted
- Diffraction!!!

Decreases on-axis irradiance Increases intensity ripple


## Spatial filtering

Surface roughness, dust, etc., adds high-spatial-frequency noise to beam profiles

Place pinhole at common foci of
 telescope to clean up the beam

For 1\% ripple, pinhole diameter D ~ 4.6wo

Example:


$$
\begin{aligned}
& \mathrm{f}=50 \mathrm{~mm} \\
& \lambda=633 \mathrm{~nm} \\
& \mathrm{w}=1 \mathrm{~mm}
\end{aligned} \longrightarrow w_{0} \cong \frac{\lambda f}{\pi w} \longrightarrow w_{0}=10 \mu \mathrm{~m}, \text { so choose } \mathrm{D}=50 \mu \mathrm{~m}
$$

## Beam expander alignment

Step 1. Adjust the beam to be parallel to be the optical table

- choose an "operating height"
- have several pinholes at this height

Step 2. Center lens 1 in the beam path

Step 3. Center lens 2 in the beam path, $\sim f 1+f 2$ from lens 1
Step 4. Adjust lens 2 position along beam until beam diameter is approximately constant between lens 2 and the wall


## Collimation test with a shearing plate

Step 5. Do a fine adjustment of lens 2 position with a shearing plate


# Reflections, coatings, polarization, and stuff 

## Fresnel reflection

An incident wave ( $E_{i}$ ) will create a reflected wave ( $E_{r}$ ) and transmitted wave ( $E_{t}$ ) The fields are decomposed with repect to the plane of incidence


## Fresnel coefficients



Brewster angle incidence provides perfect transmission for p-polarized


Reflectance is total for $\theta_{i}>\theta_{c}$

## Optical coatings - quarter wave rule

Consider a thin film of quarterwave optical thickness

substrate


If film is exactly $\lambda / 4$ thick $\left(=\lambda_{0} /\left(4 n_{f}\right)\right)$ can transform to an exact two-layer system


Now can use Fresnel reflection equations for the equivalent interfaces

## Optical coatings - half wave rule



## Antireflection coatings



For normal incidence, Fresnel reflectance is

$$
R=\left[\frac{n_{i}-n_{s}}{n_{i}+n_{s}}\right]^{2}
$$

If the substrate is coated with a $\lambda / 4$ film, we can use the quarter-wave rule...

$$
R=\left[\frac{n_{i}-n_{f}^{2} / n_{s}}{n_{i}+n_{f}^{2} / n_{s}}\right]^{2}
$$

Reflectance is zero when numerator is zero (when $n_{f}=\sqrt{n_{i}} n_{s}$ )
example: $\mathrm{n}_{\mathrm{s}}=1.5$ (glass), $\mathrm{n}_{\mathrm{f}}=1.38(\mathrm{MgF}), \mathrm{n}_{\mathrm{i}}=1 ; \mathrm{R} \sim 1.3 \%$

## AR coatings - what's the trick?

$$
\delta=\frac{2 \pi n d}{\lambda_{0}}
$$

When path difference $\mathrm{d}=\mathrm{N} / 2$, the phase difference $\delta=\pi$ .... so the two reflected waves destructively interfere


For non-normal incidence, require $\delta=\pi$ for the refracted paths

$$
\delta=\frac{2 \pi n d \cos \theta}{\lambda_{0}} \quad \begin{aligned}
& \text { Non-normal incidence shifts } \\
& \text { minimum reflectance to shorter } \\
& \text { wavelength }
\end{aligned}
$$

## AR coating performance



Single-layer MgF coating

Multi-layer "V-coating"


## High-reflectance coatings



Incident light
$\frac{\frac{n_{i}}{n_{H}}}{\frac{n_{L}}{n_{H}}} \frac{1}{n_{L}}$ for $x$ layers on $n_{H}$ and $x-1$ layers $n_{L}$

$$
R=\left[\frac{n_{i}-\frac{n_{H}^{2 x}}{n_{L}^{2 x-2} n_{s}}}{n_{i}+\frac{n_{H}^{2 x}}{n_{L}^{2 x-2} n_{s}}}\right]^{2}
$$

$$
\text { maximize } n_{H} / n_{L}
$$

## Multilayer reflector performance



Non-normal incidence shows polarization dependence

Caution: may not be suitable for ultrafast lasers

Can achieve R> 99.9\% off-the-shelf five-9's possible ... limited by losses

Damage thresholds> $10 \mathrm{~J} / \mathrm{cm}^{2}$ ( 10 ns pulse)


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## Metallic mirror performance



Damage thresholds 10x to 100x lower than dielectric stacks



## Wave polarization

The polarization state is defined by the direction of the transverse E-field


Any polarization can be decomposed into orthogonal components


## Retarders (aka waveplates)

Retarders induce a phase difference $\Delta \Phi$ between orthogonally polarized components of light

Linear retarders produce $\Delta \Phi=\Phi_{\mathrm{x}}-\Phi_{\mathrm{y}}$

- waveplates use optically anisotropic materials with linear birefringence $\Delta n=n_{x}-n_{y}$
- electro-optic materials (Pockel's effect): $\Delta n=f(E)$

- rhombs use retardance from total-internal-reflection

Circular retarders produce $\Delta \Phi=\Phi_{\text {rcp }}-\Phi_{\text {Icp }}$


- optically active chiral materials (sugar solution) with circular birefringence $\Delta n=n_{\text {rcp }}-n_{\text {lpp }}$
- magneto-optic effects: $n_{\text {rep }}-n_{\text {lcp }}=f(H)$

Retarders can rotate or transform the polarization state

## Polarizers

Birefringent crystal polarizers - extinction ratios of $10^{-5}$ to $10^{-7}$ are possible these operate through TIR so have limited acceptance angle


Dichroic polarizers cheap, limited power-handling capability extinction ratio $\sim 10^{-2}$ to $10^{-5}$ in visible


How do you determine the polarizer's transmission axis? look at the glare from a shiny surface... s-polarization "skips", p-polarization "plunges"


## Jones calculus

$\begin{aligned} & \text { Jones calculus is a tool for calculating the } \\ & \text { evolution of completely polarized beams }\end{aligned}\left[\begin{array}{l}E_{x} \\ E_{y}\end{array}\right]_{\text {out }}=\left[\begin{array}{ll}a_{2} & b_{2} \\ c_{2} & d_{2}\end{array}\right]\left[\begin{array}{ll}a_{1} & b_{1} \\ c_{1} & d_{1}\end{array}\right]\left[\begin{array}{l}E_{x} \\ E_{y}\end{array}\right]_{\text {in }}$

| Jones vectors (for fields) | Jones matrices (for components) |
| :---: | :---: |
| Linear along $\mathrm{x} \quad\left[\begin{array}{l}1 \\ 0\end{array}\right]$ | Polarizer at $0^{\circ} \quad\left[\begin{array}{ll}1 & 0 \\ 0 & 0\end{array}\right]$ |
| Linear along y $\quad\left[\begin{array}{l}0 \\ 1\end{array}\right]$ | Polarizer at $\theta^{\circ} \quad\left[\begin{array}{cc}\cos ^{2} \theta & \sin \theta \cos \theta \\ \sin \theta \cos \theta & \sin ^{2} \theta\end{array}\right]$ |
| Linear at $45^{\circ} \quad \frac{1}{\sqrt{2}}\left[\begin{array}{l}1 \\ 1\end{array}\right]$ | Quarter wave retarder at $0^{\circ}$$\quad\left[\begin{array}{cc}e^{i \pi / 4} & 0 \\ 0 & e^{-i \pi / 4}\end{array}\right]$ |
| Right-circular $\frac{1}{\sqrt{2}}\left[\begin{array}{l}1 \\ i\end{array}\right]$ | Quarter wave retarder at $45^{\circ}$$\quad \frac{1}{\sqrt{2}}\left[\begin{array}{ll}1 & i \\ i & 1\end{array}\right]$ |
| Left circular $\frac{1}{\sqrt{2}}\left[\begin{array}{c}1 \\ -i\end{array}\right]$ | Half wave retarder at $0^{\circ}$$\quad\left[\begin{array}{cc}1 & 0 \\ 0 & -1\end{array}\right]$ |

## Jones calculus example



$$
\left[\begin{array}{l}
E_{x} \\
E_{y}
\end{array}\right]_{\text {out }}=\left[\begin{array}{ll}
1 & 0 \\
0 & 0
\end{array}\right] \quad \frac{1}{\sqrt{2}}\left[\begin{array}{ll}
1 & i \\
i & 1
\end{array}\right] \quad\left[\begin{array}{l}
1 \\
0
\end{array}\right]_{\text {in }}
$$

$$
\begin{aligned}
& \qquad=\frac{1}{\sqrt{2}}\left[\begin{array}{l}
1 \\
0
\end{array}\right] \quad I=E E^{*}=\frac{1}{2} \\
& \text { Output polarization } \\
& \text { is linear vertical }
\end{aligned} \begin{aligned}
& \text { Optical power } \\
& \text { is halved }
\end{aligned}
$$

## Polarization control

## Desired polarization control

Linear-to-linear
$\lambda / 2$ plate rotates state by $2 \theta$


Linear-to-arbitrary


Arbitrary-to-arbitrary


Linear input attenuator
$\lambda / 2$ between crossed polarizers $T=\sin ^{2} \theta$


Linear input "pseudo-isolator"
requires unchanged reflection polarization


Optical isolator
magneto-optic rotatator between crossed polarizers


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## "Unpolarized" light

## Monochromatic light is polarized

$$
\vec{E}(z, t)=\hat{x} E_{x} \cos \left(\omega t-k_{0} z+\phi_{x}\right)+\hat{y} E_{y} \cos \left(\omega t-k_{0} z+\phi_{y}\right)
$$

- For strictly monochromatic light Ex, Ey, $\varphi x, \& \varphi y$ are constant
- in other words, one cannot make an unpolarized monochromatic laser beam
- exception is spatial depolarization using ground glass or integrating spheres

For non-monochromatic light, pairs $\mathrm{E}_{\mathrm{x}} \& \mathrm{E}_{\mathrm{y}}$, and $\varphi_{\mathrm{x}} \& \varphi_{\mathrm{y}}$ have statistical correlations that depend the spectral bandwidth $\Delta \omega$ of the light

For quasi-monochromatic (with bandwidth $\Delta \omega$ around $\omega_{0}$ ) light the time scale of this correlation is the coherence time $T_{c} \sim 2 \pi / \Delta \omega$ (or coherence length $L_{c}=c T_{c}$ )

Can "depolarize" broadband light with a Lyot depolarizer

Requires thick birefringent retarders with $\Delta n L>L_{c}$


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